



EMBL Workshop

From 3D Light to 3D Electron Microscopy

This workshop is jointly organised by ZEISS and EMBL

13–16 March 2016

EMBL Advanced Training Centre
Heidelberg | Germany

Keynote Speakers

Winfried Denk

Max Planck Institute of Neurobiology (MPIN), Germany

Fred Hamprecht

IWR and Department of Physics and Astronomy,
Heidelberg Collaboratory for Image Processing (HCI),
Germany

Organisers | EMBL

Yannick Schwab

EMBL Heidelberg, Germany

Nicole Schieber

EMBL Heidelberg, Germany

Organisers | Zeiss

Robert Kirmse

Carl Zeiss Microscopy GmbH, Germany

Hans-Jürgen Oberdiek

Carl Zeiss Microscopy GmbH, Germany

Co-Organisers

Chris Guerin

VIB Ghent, Belgium

Saskia Lippens

VIB Ghent, Belgium

Confirmed Speakers

Ilya Belevich

Institute of Biotechnology,
University of Helsinki, Finland

Silke Christiansen

Helmholtz-Zentrum Berlin, Germany

Lucy Collinson

Francis Crick Institute, UK

Thomas Deerinck

University of California,
San Diego, USA

Christel Genoud

Friedrich Miescher Institute for
Biomedical Research, Switzerland

Ben Giepmans

UMCG, The Netherlands

Chris Guerin

VIB Ghent, Belgium

Jan Harapin

University of Zurich, Switzerland

Eija Jokitalo

University of Helsinki, Finland

Matthia Karreman

EMBL Heidelberg, Germany

Graham Knott

EPFL Lausanne, Switzerland

Anna Kreshuk

IWR and Heidelberg Collaboratory
for Image Processing (HCI),
University of Heidelberg,
Germany

Peter O'Toole

University of York, UK

Perrine Paul-Gilloteaux

University of Nantes,
France

Richard Webb

University of Queensland,
Australia

Roger Wepf

IETH Zurich, Switzerland



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ONLINE REGISTRATION ONLY

www.embl.de/3Dclem

Abstract deadline is 18 December 2015

Application deadline is 28 January 2016

Registration fees

Academia	200.00 €
PhD student	200.00 €
Industry	400.00 €

Contact

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